

# ELECTRONIC INFORMATION DISCLOSURE STATEMENT

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## Title of Invention

SEMICONDUCTOR DEVICE AND SEMICONDUCTOR  
SUBSTRATE, AND METHOD OF FABRICATING THE SAME

Application Number :

Confirmation Number:

First Named Applicant: Masahiro ISHIDA

Attorney Docket Number: 28569.4136

Art Unit: 2811

Examiner: Sara W. Crane

Search string: ( 6111277 or 6337233 or 5834325 or 6121634 or 6153010 or 6015979 or 6051849  
or 6177688 or 5285086 or 5032893 or 5294808 or 5208182 ).pn

## US Patent Documents

**Note: Applicant is not required to submit a paper copy of cited US Patent Documents**

init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass
	1	6111277	2000-08-29	Ikeda			
	2	6337233	2002-01-08	Kim, et al.			
	3	5834325	1998-11-10	Motika, et al.			
	4	6121634	2000-09-19	Saito, et al.			
	5	6153010	2000-11-28	Kiyoku, et al.			
	6	6015979	2000-01-18	Sugiura, et al.			
	7	6051849	2000-04-18	Davis, et al.			
	8	6177688	2001-01-23	Linthicum, et al.			
	9	5285086	1994-02-08	Fitzgerald, et al.			
	10	5032893	1991-07-16	Fitzgerald, Jr., et al.			
	11	5294808	1994-03-15	Lo			
	12	5208182	1993-05-04	Narayan, et al.			

## Signature

Examiner Name	Date